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JFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : N. Sakamoto et al.

Art Unit : 2815

Serial No. : 09/810,101

Examiner : Sheila Clark

Filed : March 16, 2001

Title : RADIATION SUBSTRATE AND SEMICONDUCTOR MODULE

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 30, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

September 29, 2004

Signature

Paula F. Romeo

PAULA T. ROMEO

Typed or Printed Name of Person Signing Certificate